



# Electrochemical synthesis of fluoro-organosilanes

B.I. Martynov <sup>a</sup>, A.A. Stepanov <sup>b</sup>

<sup>a</sup> State Research Institute of Organic Chemistry and Technology, 23, Shosse Entuziastov, Moscow 111024, Russia <sup>b</sup> A.N. Nesmeyanov Institute of Organoelement Compounds, Russian Academy of Sciences, 28, Vavilov street, Moscow 117813, Russia

Received 12 December 1996; accepted 7 April 1997

### **Abstract**

The electrochemical reduction of some fluorohalocarbons in the presence of trimethylchlorosilane is followed by formation of the corresponding fluoroalkyltrimethylsilanes. CF<sub>3</sub>SiMe<sub>3</sub>, CFCl<sub>2</sub>SiMe<sub>3</sub>, CF<sub>3</sub>CCl<sub>2</sub>SiMe<sub>3</sub> and (EtO)<sub>2</sub>P(O)CF<sub>2</sub>SiMe<sub>3</sub> were obtained with current efficiency 20–50%. Voltammetric data are presented. © 1997 Elsevier Science S.A.

Keywords: Fluoro-organosilanes; Fluorohydrocarbons; Fluoroalkylation; Silylation; Electrochemical reduction

### 1. Introduction

Fluoroalkyltrimethylsilanes are useful reagents for introduction of the fluoroalkyl substituents into organic molecules [1].

Traditional methods of their synthesis include the reaction with non-readily available tris-dialkylamidophosphites [2]. At the same time the electrochemical reduction (ECR) of carbon tetrachloride and chloroform in the presence of trimethylchlorosilane (TMCS) enables di- and trichloromethylsilane formation [3]. Trifluorobromomethane under analogous conditions reacts with the solvent [4], although the authors observed the "silylated" products if a large excess of TMCS was used. Recently electrochemical synthesis of  $CF_3SiMe_3$  has been described [5].

It was our purpose to expand the direct method of electrochemical synthesis of fluoroalkyltrimethylsilanes with various fluoroalkyl substituents.

### 2. Results and discussion

The preparative electrolysis of some fluorocarbons in DMF on a stainless steel cathode with a sacrificial Zn anode in the presence of TMCS excess was established to produce the corresponding haloalkylsilanes:

The results of electroreduction are presented in Table 1. The produced silanes have been identified by <sup>19</sup>F-NMR, chromato-mass spectra and GLC. Silanes **IX**, **XI**, **XII** are identical to authentic samples [2,6,7]. ECR of difluorodibromomethane (**VI**) under the same conditions does not afford Me<sub>3</sub>SiCF<sub>2</sub>Br. Trifluorotrichloroethane (**VII**) undergoes more complicated transformations, which are now under study.

We did not observe the reduction of trimethylchlorosilane at up to -2.7 V by voltammetry (DMF,  $Et_4NBF_4$ , SCE, glassy carbon). The sole peak (-2.14 V) on the voltammogram, being unaffected by water addition, might be related to HCl reduction, produced by trimethylchlorosilane hydrolysis. So the reaction scheme seems to be as follows.

$$R_fX + 2e \rightarrow R_f^- + X^-$$
  
 $R_f^- + ClSiMe_3 \rightarrow R_fSiMe_3 + Cl^-$ 

Generation of the fluoroalkyl carbanion is a fast two-electron irreversible process, the silylation stage is more slow, and for reduction of carbon tetrachloride in the presence of trimethychlorosilane  $CCl_3SiMe_3$  was observed as a peak on the voltammogram ( $E_p - 2.3 \text{ V}$ ) at low scan rates (0.1–0.5 V s<sup>-1</sup>). At the scan rate 50 V s<sup>-1</sup> this peak is absent.

Reduction potentials of silanes IX and X are also about -2.4 V and, in galvanostatic conditions of electrolysis, they are also partially reduced. On reduction of trifluorotrichloroethane (III), besides the main product, the following compounds were detected:

$$CF_2 = CC1SiMe_3$$
  $CF_2 = C(SiMe_3)_2$   $Me_3SiC \equiv CSiMe_3$ 

Table 1 Electrochemical silylation of fluorohalogen compounds

Compound	$-E_{p}(V)^{a}$	Product	Current efficiency (%)
CCl <sub>4</sub> (I)	1.49	CCl <sub>3</sub> SiMe <sub>3</sub>	[3]
CFCl <sub>3</sub> (II)	1.82	CFCl <sub>2</sub> SiMe <sub>3</sub> ( <b>IX</b> )	50
CF <sub>3</sub> CCl <sub>3</sub> (III)	1.61	$CF_3CCl_2SiMe_3(X)$	18
CF <sub>2</sub> CBr <sub>2</sub> (IV)	1.51	<u> </u>	_
$CF_{3}I(\mathbf{V})$	1.72	$CF_3SiMe_3(XI)$	32
CF <sub>3</sub> Br (VI)	1.92	(XI)	[5]
CF <sub>2</sub> ClCFCl <sub>2</sub> (VII)	2.04	<u> </u>	
$BrCF_2P(O)(OEt)_2(VIII)$	1.87	$(EtO)_2P(O)CF_2SiMe_3(XII)$	40

a Reduction potentials were obtained on a stationary glassy carbon electrode in DMF solution with 0.1 M Et<sub>4</sub>NBF<sub>4</sub> as supporting electrolyte, vs. SCE.

Silanes XI and XII are not electroactive under electrolysis conditions, and difluorophosphonate, formed as a by-product in the silane XII synthesis, arises from the concurrent reaction of the intermediate anion with solvent:

$$(EtO)_2P(O)CF_2Br \rightarrow (EtO)_2P(O)CF_2H 5\%$$

We also tried to realise the chemical synthesis of fluoro-dichloro- and trichloro-methyltrimethylsilanes in conditions close to that of electrolysis. The reaction of Zn powder with trichlorofluoromethane or carbon tetrachloride in dimethyl-formamide or N-methylpyrrolidone in the presence of trimethylchlorosilane appeared to produce the desirable silanes in high yields at very low (<5%) conversion. The conversion increase leads to a sharp decrease of the yield, probably caused by the further reduction of the silane.

## 3. Experimental

<sup>19</sup>F-NMR spectra were recorded on a Bruker AC-200 utilising trifluoroacetic acid as an external standard. Chromatomass spectra were obtained on a "VGMS 70-70 E" instrument. Dimethylformamide was distilled from phosphorus pentoxide at reduced pressure, trimethylchlorosilane in an inert atmosphere from Mg powder. Voltammetry measurements were made with polarographic analyzer PA-2 (Praha), preparative electrolysis was made with potentiostat P-5827M in an atmosphere of dry argon.

### 3.1. General procedure

The mixture of 50 ml DMF, 15 ml TMCS and 0.2 g Et<sub>4</sub>NBF<sub>4</sub> was placed in an undivided electrochemical cell, equipped with a stainless steel cathode (50 cm<sup>2</sup>), a Zn anode (8 mm diameter rod) and a magnetic stirrer, and pre-electrolysis was carried out at a current of 100 mA during 1 h. Then 0.01–0.08 M of fluorohalocarbon was added and electrolysed with 2.1 F current consumption at a current density of 10 mA cm<sup>-2</sup>. Electrolyte was extracted with an ether-

pentane 1:1 mixture, washed with saturated NaCl water solution, dried and distilled.

## 3.1.1. Fluorodichloromethyltrimethylsilane (IX)

Yield 50%; b.p. 131 °C; <sup>19</sup>F-NMR (without solvent):  $\delta_F = 0.9 \text{ ppm}$  (s). Lit. [2].

3.1.2. 2,2,2-Trifluoro-1,1-dichhloroethyltrimethylsilane (X) Yield 18%; <sup>19</sup>F-NMR (without solvent):  $\delta_F$  – 4.6 ppm (s). m/z: 151 ( $C_2F_3Cl_2^+$ ), 73 ( $Me_3Si^+$ ). Lit. [8].

## 3.1.3. Trifluoromethyltrimethylsilane (XI)

Yield 32% b.p.; 45 °C; <sup>19</sup>F-NMR (without solvent):  $\delta_F - 11.0 \text{ ppm (s)}$ . Lit. [6].

3.1.4. Trimethylsilyldifluoromethanephosphonic acid diethyl ester (XII)

Yield 40%; <sup>19</sup>F-NMR (without solvent):  $\delta_F$  52.3 ppm (d,  $J_{P-F}$  = 95 Hz). Lit. [7].

## Acknowledgements

We wish to thank the International Science and Technology Center (ISTC project No 136-94) for financial support of this research.

#### References

- [1] G.K.S. Prakash, R. Krishnamutri, G.A. Olah, J. Am. Chem. Soc. 111 (1989) 393.
- [2] R. Josten, I. Ruppert, J. Organoment. Chem. 329 (1987) 313.
- [3] P. Pons, C. Biran, M. Bordeau, J. Dunguens, J. Organomet. Chem. 358
- [4] S. Sibille, J. Perrichon, J. Chaussard, Synth. Commun. 19 (1989) 2449.
- [5] G.K.S. Prakash, D. Deffieux, A.K. Yudin, G.A. Olah, Synth. Lett. (1994) 1057
- [6] I. Ruppert, K. Schlich, W. Volbach, Tetrahedron Lett. 25 (1984) 2195.
- [7] M. Obayashi, E. Ito, K. Matsui, K. Kondo, Tetrahedron Lett. 23 (1982) 2323.
- [8] D. Seyferth, D.C. Mueller, F.M. Ambrecht, Organomet. Chem. Synth. 1 (1970) 3.

<sup>&</sup>lt;sup>b</sup> At two electron process.